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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Su, et al. Attorney Docket.: TSM03-0150  
Serial No.: 10/675,862 Art Unit: 2812  
Filed: September 30, 2003 Examiner: Unknown  
For: Apparatus And Method For Manufacturing A Semiconductor Wafer With Reduced Delamination And Peeling

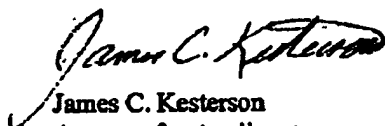
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**REQUEST UNDER 37 C.F.R. § 1.48**

This is a request for correction in inventorship in the above patent application. In accordance with 37 C.F.R. § 1.48, Applicants assert that the failure to include the eighth inventor's name, Chenming Hu, arose without any deceptive intention and was inadvertent on the part of the Applicants. The statements required under 37 C.F.R. § 1.48 are attached.

The fee of \$130.00 required under 37 C.F.R. § 1.17(i) is authorized to be charged to Deposit Account No. 50-1065. Please charge any additional fees required by this paper or credit any overpayment to this account. A duplicate of this paper is attached.

Respectfully submitted,



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